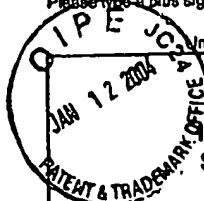


Please type a plus sign (+) inside this box. +

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.



Substitute for Form 1449A/PTO

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet

1

of

Complete If Known	
Application Number	09/876,292
Filing Date	08/07/01
First Named Inventor	Mahalingam Nandakumar, et al.
Group Art Unit	2815
Examiner Name	Edgardo Ortiz
Attorney Docket No.	TI-31089

U.S. PATENT DOCUMENTS					
Exam. Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)
		Number	Kind Code ² (if known)		
ED	AA	5,023,878		Kinzer	6/11/81
ED	AB	5,371,394		Ma et al.	1/26/94
ED	AC	6,174,778		Chen et al.	1/16/01
AD					
AE					
AF					
AG					
AH					
AI					
AJ					
AK					
AL					

FOREIGN PATENT DOCUMENTS					
Exam. Initials*	Cite No. ¹	Foreign Patent Document		Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)
		Office ³	Number ⁴		
BA	FR	2 786 204 A1		Aliou Jerome et al.	1/12/01
BB					
BC					
BD					
BE					
BF					
BG					

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS					
Exam. Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			
ED	CA	KUNIKIYO TATSUYA, "Semiconductor Device and its Manufacture" Patent Abstracts of Japan, Vol. 1995, No. 02, March 31, 1995, Publication Number 06316698, Publication Date November 15, 1994			
ED	CB	MORII TOMOYUKI, "MOS Type Semiconductor Device and Manufacture Thereof" Patent Abstracts of Japan, Vol. 014, No. 346, July 26, 1990, Publication Number 02119269, Publication Date May 7, 1990			
CC					
CD					
CE					
CF					
CG					

Examiner Signature	<i>Udayadevi</i>	Date Considered	<i>4/22/04</i>
-----------------------	------------------	--------------------	----------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

US and Foreign Patent Documents: ¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

Other Prior Art/Non-Patent Literature Documents: ¹Unique citation designation number. ²Applicant is to place a check mark here if English Translation is attached.